



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q66212

KIYOKU, HIROYUKI, et al.

Appln. No.: 09/986,332

Group Art Unit: 1722

Confirmation No.: 5542

Examiner: Matthew A. ANDERSON

Filed: November 8, 2001

For: NITRIDE SEMICONDUCTOR GROWTH METHOD, NITRIDE SEMICONDUCTOR SUBSTRATE,  
AND NITRIDE SEMICONDUCTOR DEVICE

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A petition and the required fee are submitted herewith for a two (2) month extension of time to extend the time period for reply to the Office Action dated July 5, 2005 from October 5, 2005 to December 5, 2005.

A Declaration under 37 C.F.R. § 1.132 (unexecuted and executed copy) is also submitted herewith.

Please consider the remarks as submitted herewith on the accompanying pages.

**REMARKS**

Claims 208-220, 235, 238 and 240-247 are all the claims pending in the application. No claims are amended.